

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	4996	((134/18) or (134/26) or (134/32) or (134/33) or (134/42)).OCLS.	USPAT; USOCR	OR	OFF	2009/04/08 11:17
L2	2210	11 and (nozzle jet \$3 spray\$3)	USPAT	OR	ON	2009/04/08 11:18
L3	245	11 and (nozzle jet \$3 spray\$3) with (reverse back)	USPAT	OR	ON	2009/04/08 11:18
L4	245	11 and (nozzle jet \$3 spray\$3) with (reverse back)	US-PGPUB; USPAT	OR	ON	2009/04/08 11:18
L5	2	(substrate and liquid and reverse and nozzle and supply and cup).clm.	US-PGPUB; USPAT	OR	ON	2009/04/08 11:19
L6	0	(substrate and liquid and reverse and nozzle and supply and cup and horizontal).clm.	US-PGPUB; USPAT	OR	ON	2009/04/08 11:19
L7	6	(substrate and liquid and reverse and nozzle and supply and horizontal).clm.	US-PGPUB; USPAT	OR	ON	2009/04/08 11:20
L8	4	(substrate and liquid and reverse and nozzle and supply and horizontal and rotat\$3).clm.	US-PGPUB; USPAT	OR	ON	2009/04/08 11:20

L9	3	(substrate and liquid and reverse and nozzle and supply and horizontal and rotat\$3 and holder).clm.	US-PGPUB; USPAT	OR	ON	2009/04/08 11:20
L10	0	(substrate and liquid and reverse and nozzle and supply and horizontal and rotat\$3 and holder and cup). clm.	US-PGPUB; USPAT	OR	ON	2009/04/08 11:21
S1	3	"6945259"	USPAT	OR	ON	2007/09/21 14:14
S2	19	"5634980"	USPAT	OR	ON	2007/09/21 15:16
S3	14	"5927303"	USPAT	OR	ON	2007/09/21 14:14
S4	30453	"134".clas.	USPAT	OR	ON	2007/09/21 15:16
S5	2272	(clean\$3 rins\$3 wash\$3) with (substrate wafer) with (nozzle jet)	USPAT	OR	ON	2007/09/21 15:17
S6	149	(clean\$3 rins\$3 wash\$3) with (substrate wafer) with (nozzle jet) with (back rear) with surface	USPAT	OR	ON	2007/09/21 15:17
S7	10	("5882433" "5906687" "5983909" "6039815" "6071376" "6277205" "6491764" "6743301" "6832616" "6837252").PN.	US-PGPUB; USPAT; USOCR	OR	ON	2007/09/24 14:20

S8	444	"134".clas. and substrate and (cup guard)	USPAT	OR	ON	2008/04/08 17:21
S9	165	(clean\$3 rins\$3 wash\$3) with (substrate wafer) with (nozzle jet) with (back rear) with surface	USPAT	OR	ON	2008/10/14 11:57
S10	2435	(clean\$3 rins\$3 wash\$3) with (substrate wafer) with (nozzle jet)	USPAT	OR	ON	2008/10/14 11:57
S11	461	"134".clas. and substrate and (cup guard)	USPAT	OR	ON	2008/10/14 11:57

4/ 8/ 2009 11:22:07 AM

C:\Documents and Settings\jheckert\My Documents\EAST\Workspaces\10-765182.wsp